INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)	SWO-0002
Application Number	10/705,591
Applicant(s)	Jeong-Hwan LEE, et al.
Filing Date	11/10/2003
Group Art Unit	2875

(OIPE stamp: OCT 2 0 2005, PATENT & TRADEMARK OFFICE, IAP86)

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO
JMH		2002-79605	03/19/2002	JAPAN				
JMH		WO 02/04858	01/17/2002	PCT				
JMH		08-327807	12/13/1996	JAPAN				

OTHER DOCUMENTS   *(Including Author, Title, Date, Pertinent Pages, Etc.)*

*EXAMINER INITIAL		
JMH		Office Action by Chinese Patent Office dated July 29, 2005.
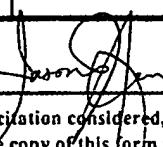
EXAMINER		DATE CONSIDERED	January 25, 2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

		Docket Number (Optional) SWO-0002	Application Number 10/705,591

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

OCT 2 0 2005

Applicant(s)
Jeong-hwan LEE, et al.

Filing Date 11/10/2003	Group Art Unit 2875

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JMH		6,683,720 B2	01/27/2004	Yoshida et al.			

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO
JMH		2000-056137	2/25/2000	JAPAN				
JMH		2000-035515	2/2/2000	JAPAN				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

JMH		Office Action by Taiwanese Patent Office dated June 21, 2005.

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-A820
(also form PTO-1449)

P09A/REV05

Patent and Trademark Office * U.S. DEPARTMENT OF COMMERCE